

Particle Size Analysis by Two-dimensional XRD

Bob He
Bruker AXS, Inc.

Particle Size Analysis by Two-dimensional XRD

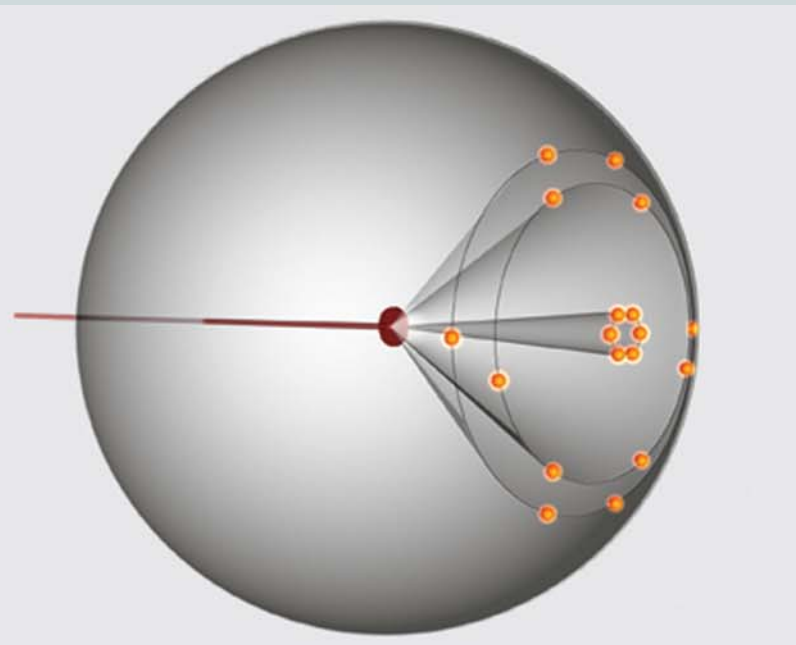
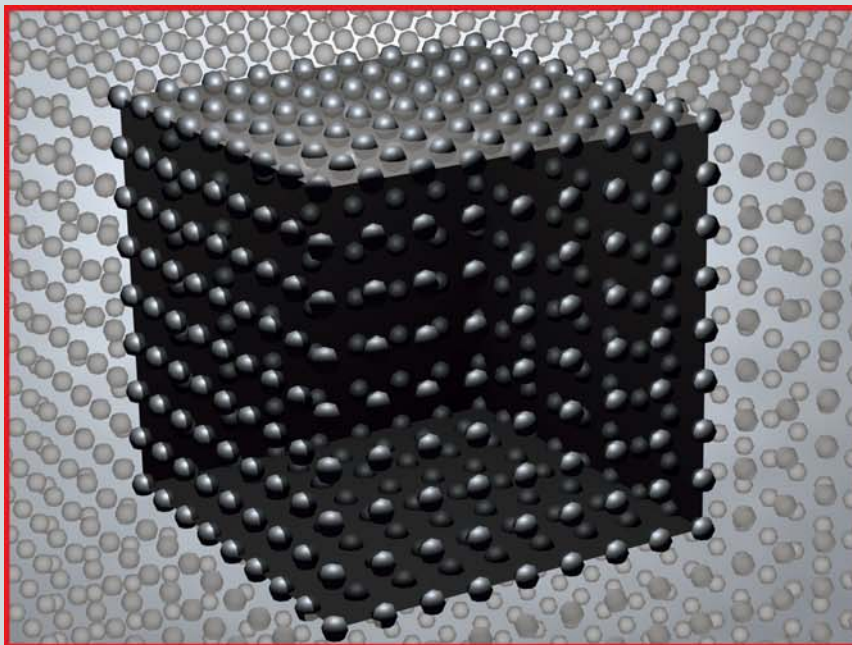


**The Eighth Pharmaceutical Powder X-ray Diffraction Symposium
4-7 May 2009 – Glasgow, Scotland, UK**

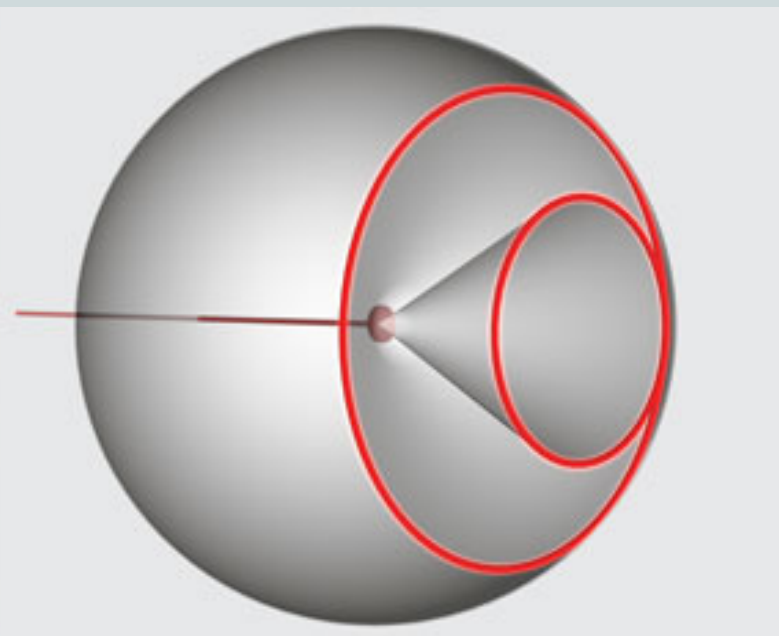
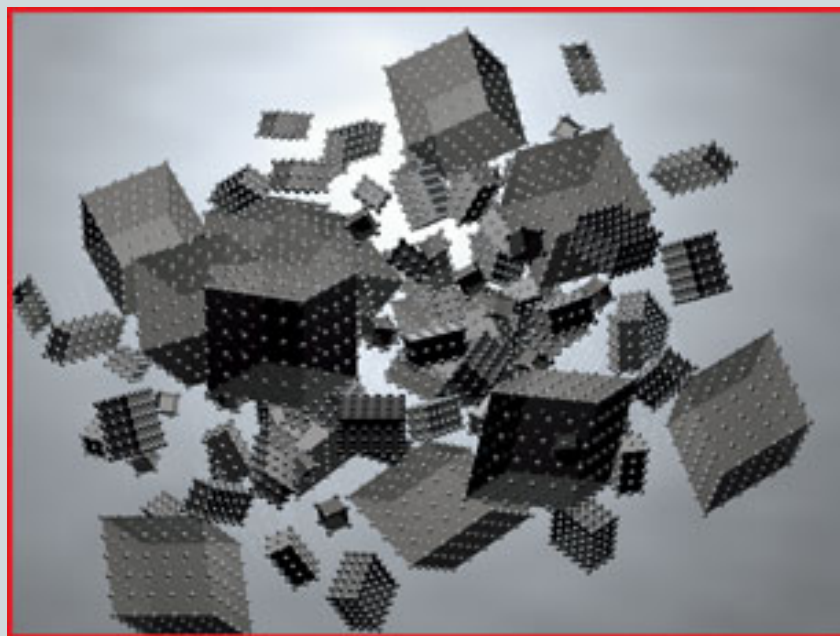
Bob B. He

- ◆ **Two-dimensional XRD**
- ◆ **Particle Size Analysis – conventional methods**
- ◆ **Particle Size Analysis –XRD² method**

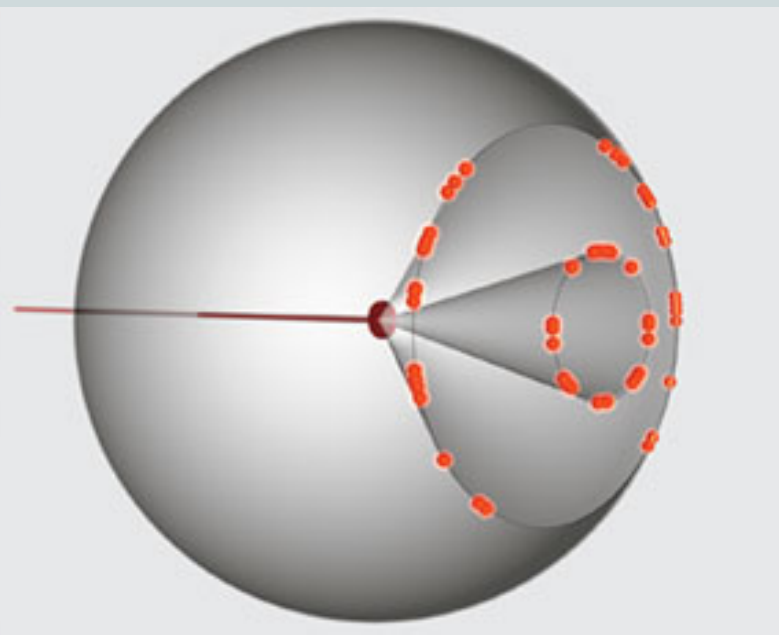
XRD² & Single Crystals



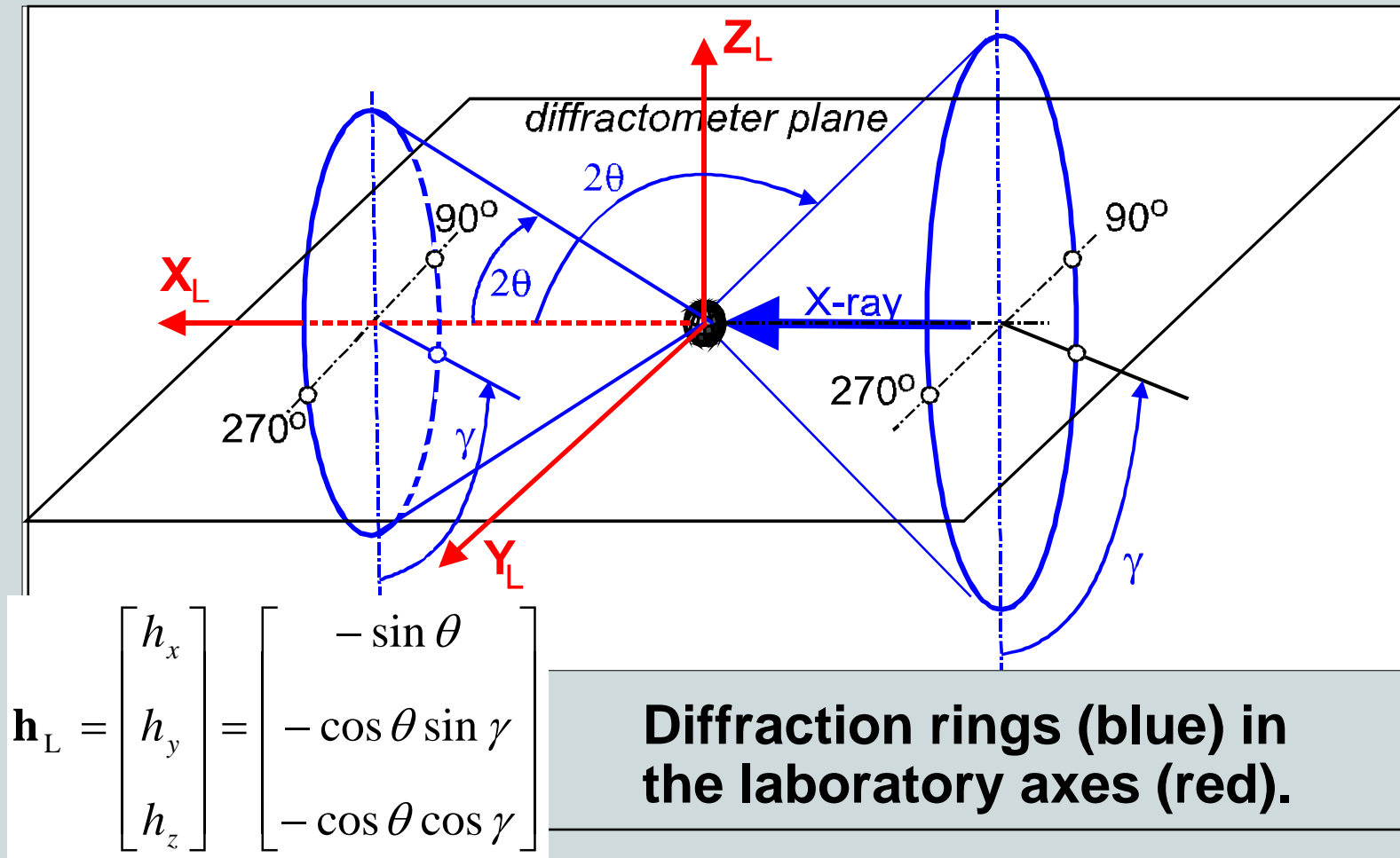
XRD ² & Powders



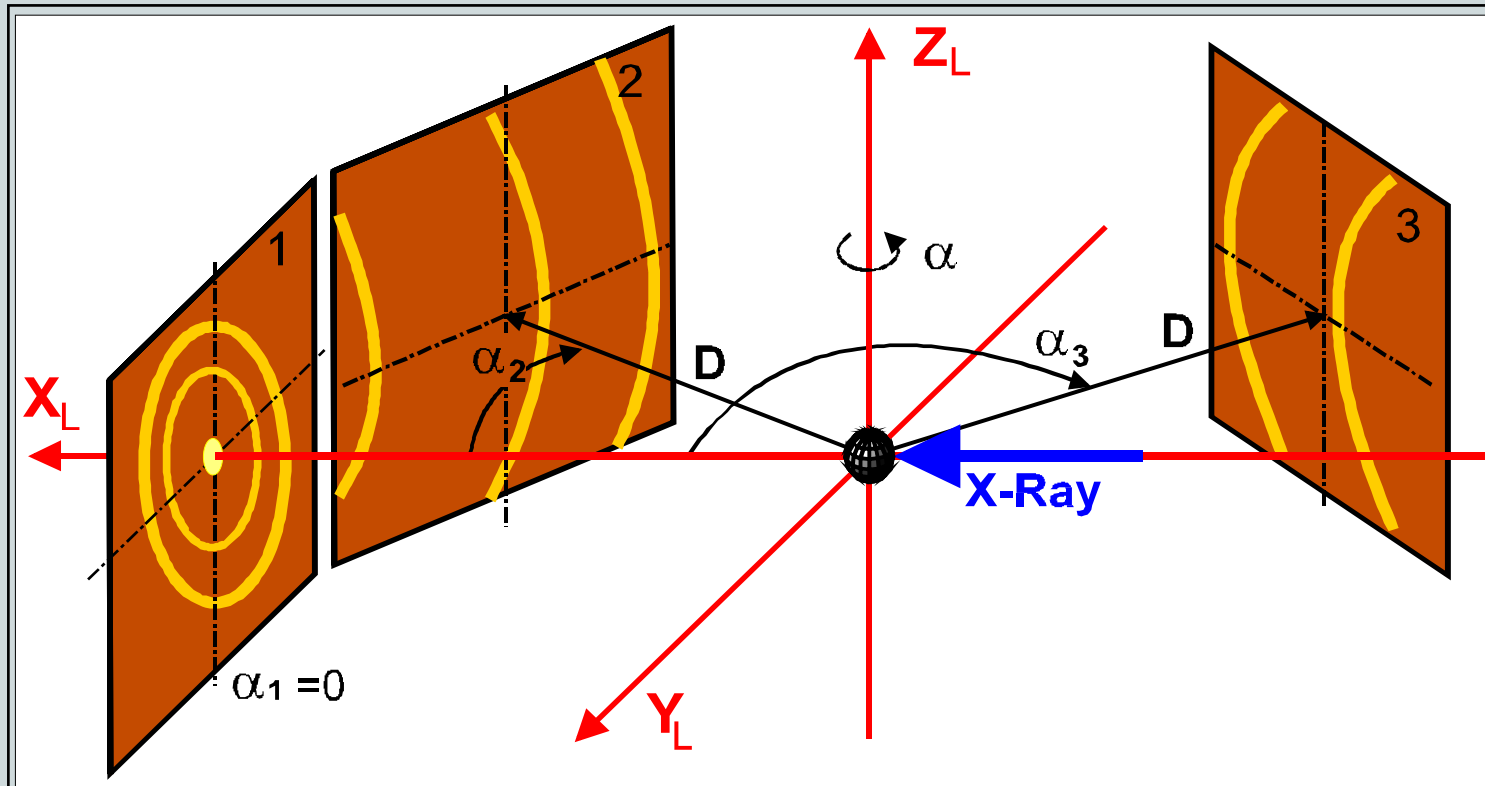
XRD² & Micro Samples or Large Grains



XRD²: Geometry Convention (1) - Diffraction Space

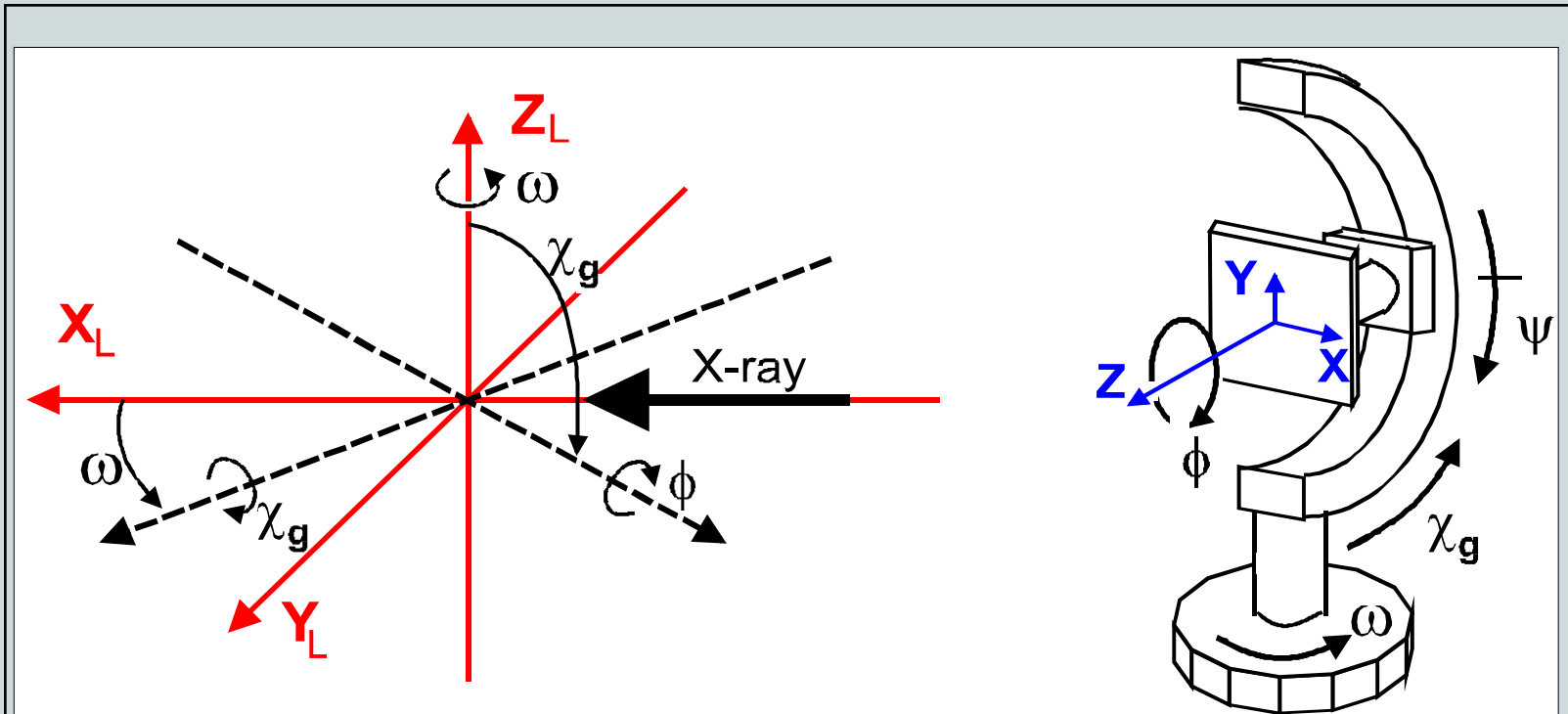


XRD²: Geometry Convention (2) - Detector Space



Detector position in the laboratory coordinates is determined by the detector distance D and swing angle α .

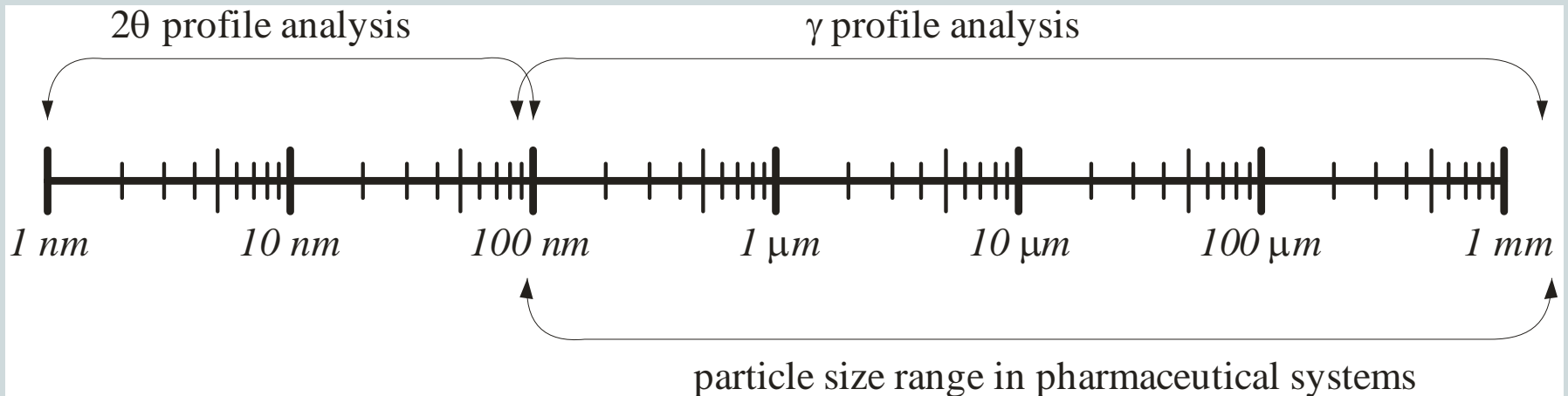
XRD²: Geometry Convention (3)- Sample Space



Rotation axes ω , ϕ , χ_g
and the laboratory
axes $X_L Y_L Z_L$ (red).

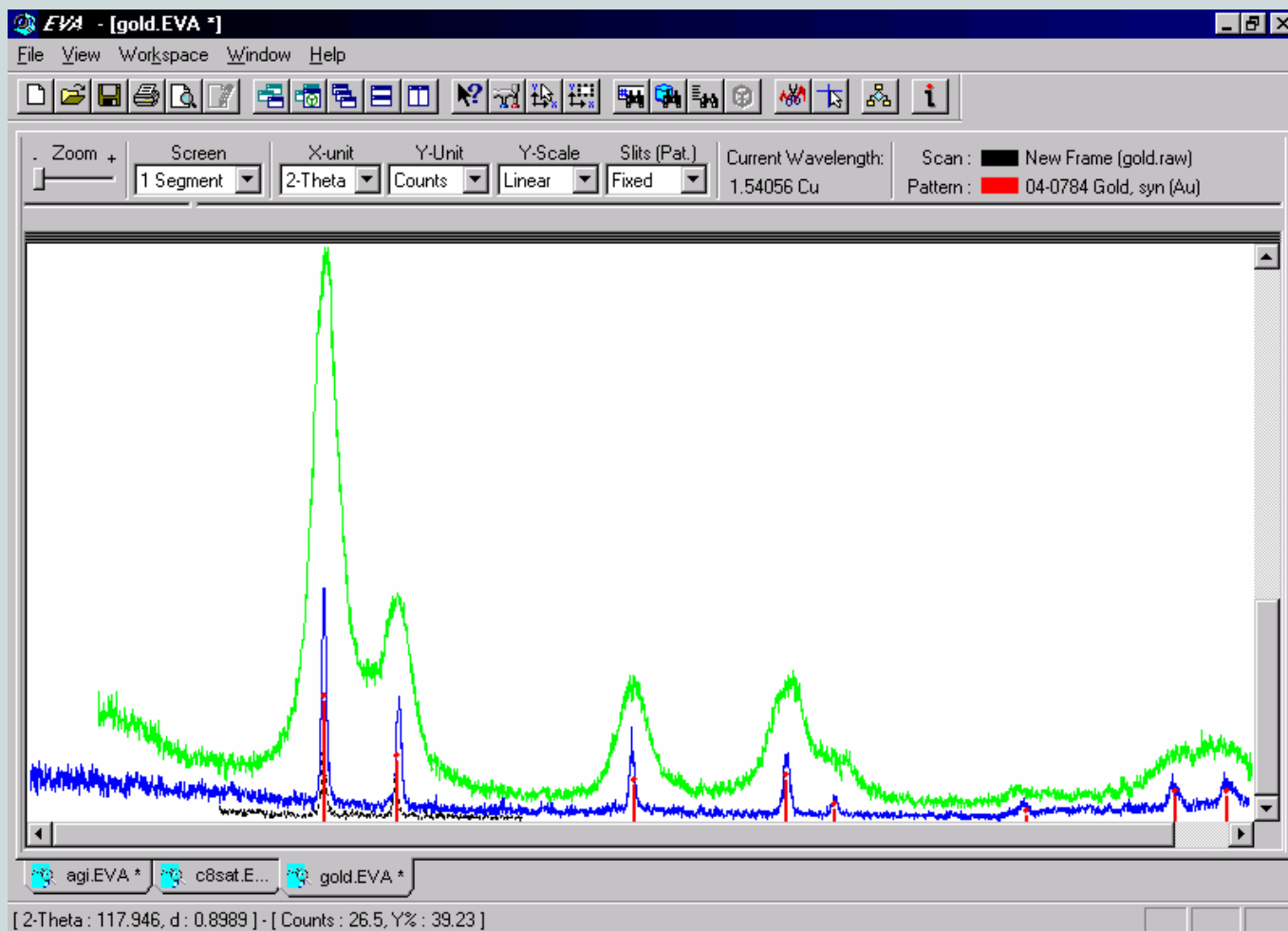
Rotation axes ω , ϕ ,
 $\chi_g(\psi)$ and translation
axes XYZ (blue).

XRD²: Particle Size Analysis by X-ray Diffraction:

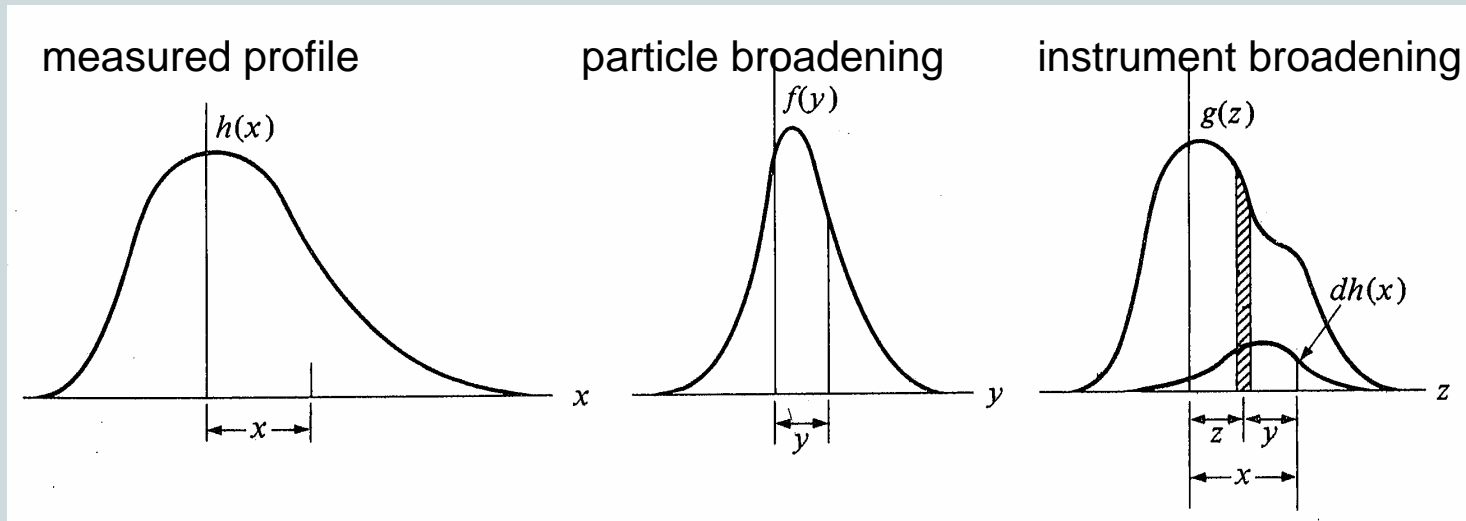


- 2θ profile analysis, including measurement from peak FWHM by Scherrer equation, or profile analysis by Stokes and Wilson, is suitable for particle size below 100 nm.
- γ profile analysis, based on sampling statistics, is suitable for particle size from sub-micrometer to a few millimeters.
- The particle size range of pharmaceutical substances is from sub-micrometer to a few millimeters.

XRD²: Peak broadening-gold Nanoparticles



XRD²: Particle size and instrument broadening:



The measured profile is a convolution of the functions representing particle-size broadening and instrument broadening

$$h(x) = \frac{1}{A} \int g(z) f(x - z) dz$$

where A is the area of the $f(y)$ curve and $y = x - z$.

Ref: B. E. Warren, *X-ray Diffraction*, Dover Publications, Inc. New York, 1990.

XRD²: Particle size calculation:

Scherrer equation:

$$t = \frac{C\lambda}{B \cos \theta}$$

where λ is wavelength (Å), B is FWHM (radians) corrected for instrument broadening, θ is Bragg angle, C is a crystal shape factor from 0.9~1.

For Gaussian profiles,

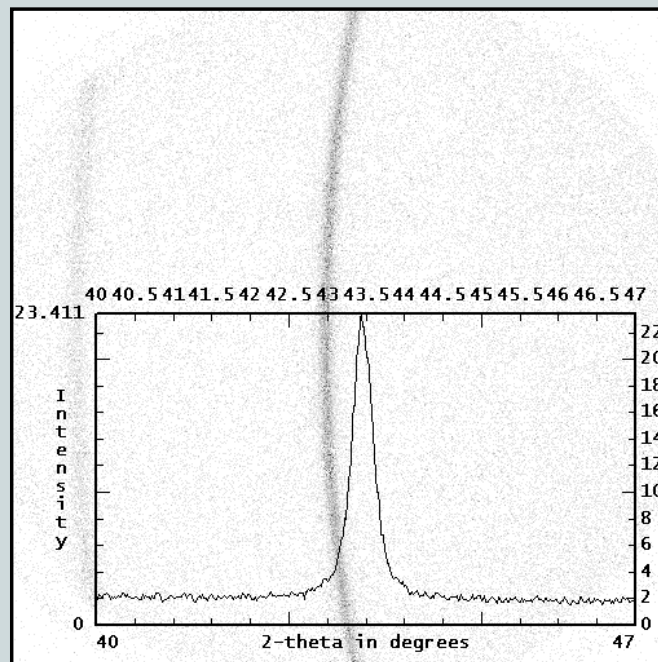
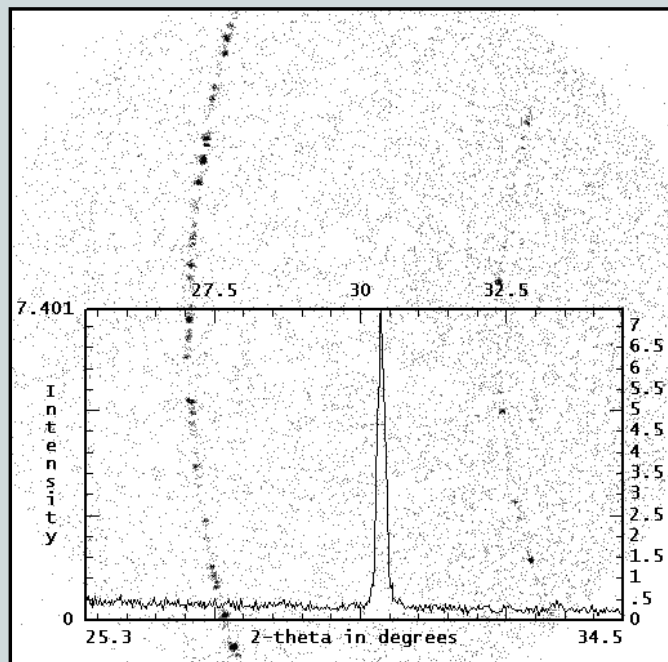
$$B^2 = U^2 - S^2$$

while for Cauchy profiles,

$$B = U - S$$

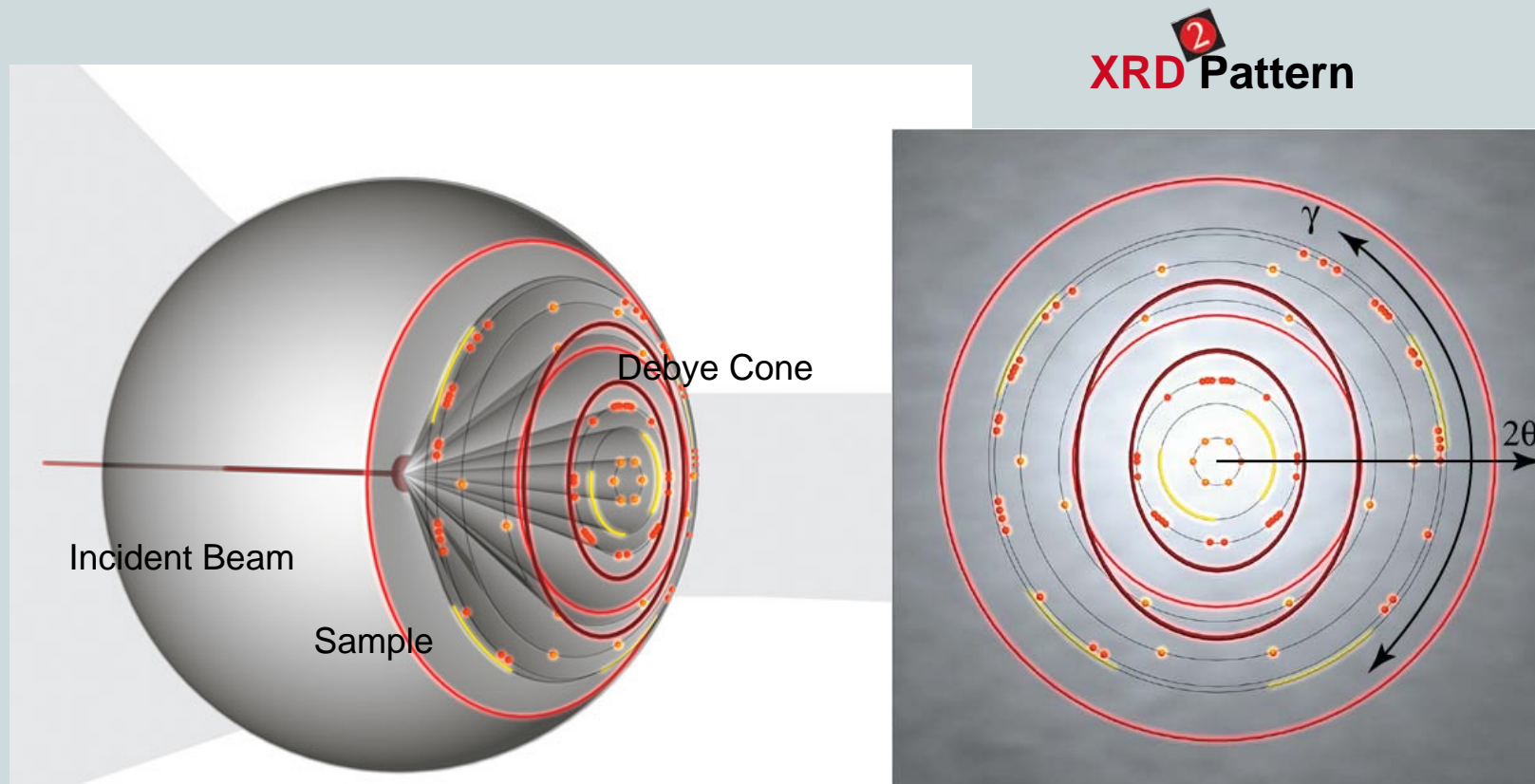
where B is the corrected FWHM for crystallite size calculation by Scherrer equation, and U and S are the FWHM's of the unknown and standard peaks, respectively.

XRD²: Particle size calculation by Scherrer equation:



- Left: NIST SRM 660, LaB6. Profile fitting of the peak shown gives a FWHM of 0.162° with a Gaussian profile and 0.133° with a Cauchy.
- Right: Cu (111) peak from a semiconductor tab tape. Profile fitting with a Cauchy function for a peak at 43.455° 2θ gives a FWHM of 0.300° .
- Using LaB6 as an instrumental broadening standard with a Cauchy FWHM of 0.133° , the corrected FWHM is 0.167° , and the Scherrer equation gives a crystallite size of 512 Å.

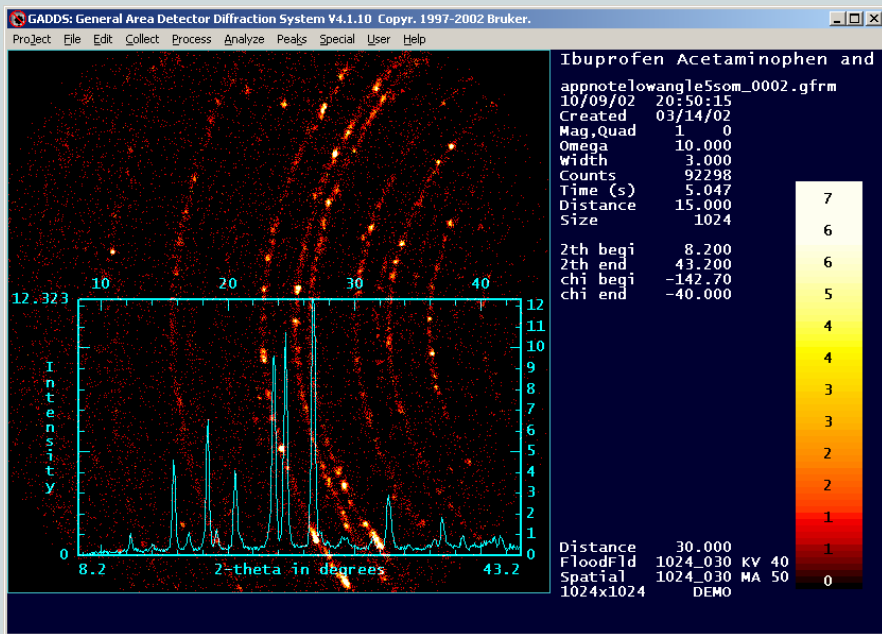
XRD²: Particle size measurement by γ profile analysis:



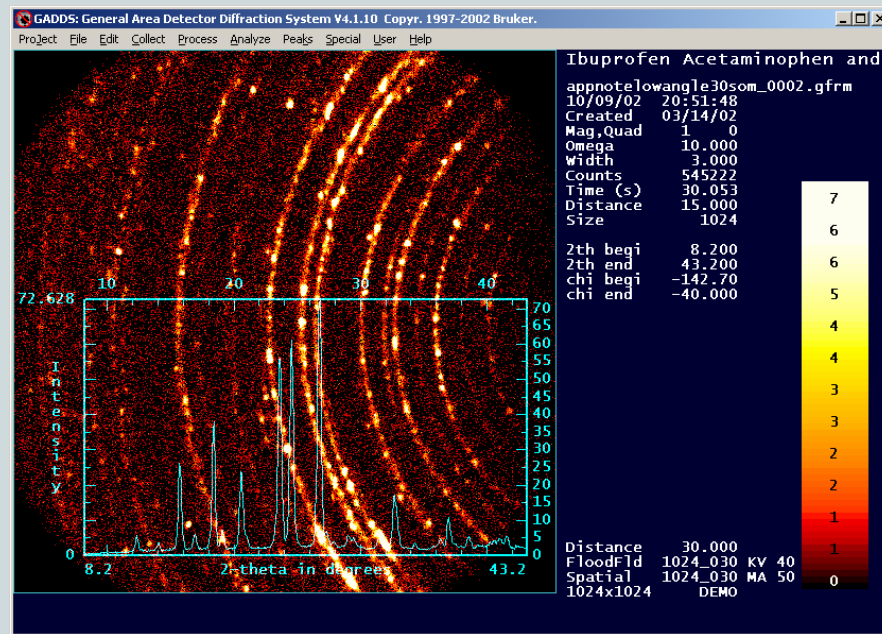
XRD²: Data Collection:

Acetaminophen powder

5 second data collection



30 second data collection



- The spotty diffraction ring is due to the large crystallites compared to the sampling volume (beam size).
- The number of spots on the ring is determined by crystallite size, instrumental window (γ -range), multiplicity of the crystal plane, and effective diffraction volume.

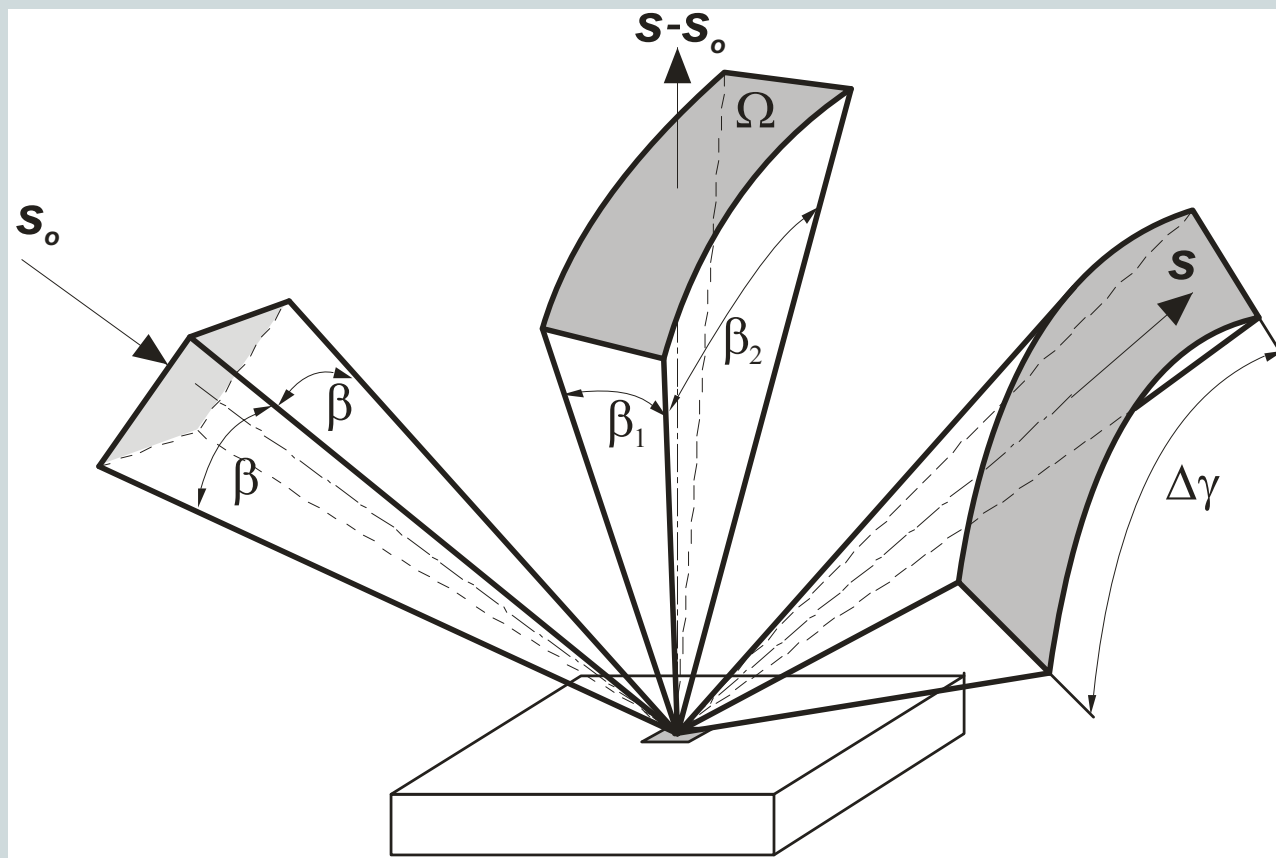
XRD²: Particle size measurement by γ profile analysis:

The sampling statistics are determined by both the sample structure and instrumentation. For a perfect random powder sample, the number of contributing crystallites for a measured diffraction line can be given by:

$$N_s = p_{hkl} \cdot \frac{Vf_i}{v_i} \cdot \frac{\Omega}{4\pi}$$

where p_{hkl} is the multiplicity of the diffracting planes,
 V is the effective sampling volume,
 f_i is the volume fraction of the crystallites being measured
and $f_i = 1$ for single phase materials,
 v_i is the volume of individual crystallites and
 Ω is the angular window of the instrument in solid angle.
The factor Vf_i / v_i is the number of the crystallites being measured within the effective volume. The factor $\Omega / 4\pi$ is the ratio of the effective volume satisfying the Bragg condition. Assuming sphere-shaped particles, $v_i = \pi d_i^3 / 6$

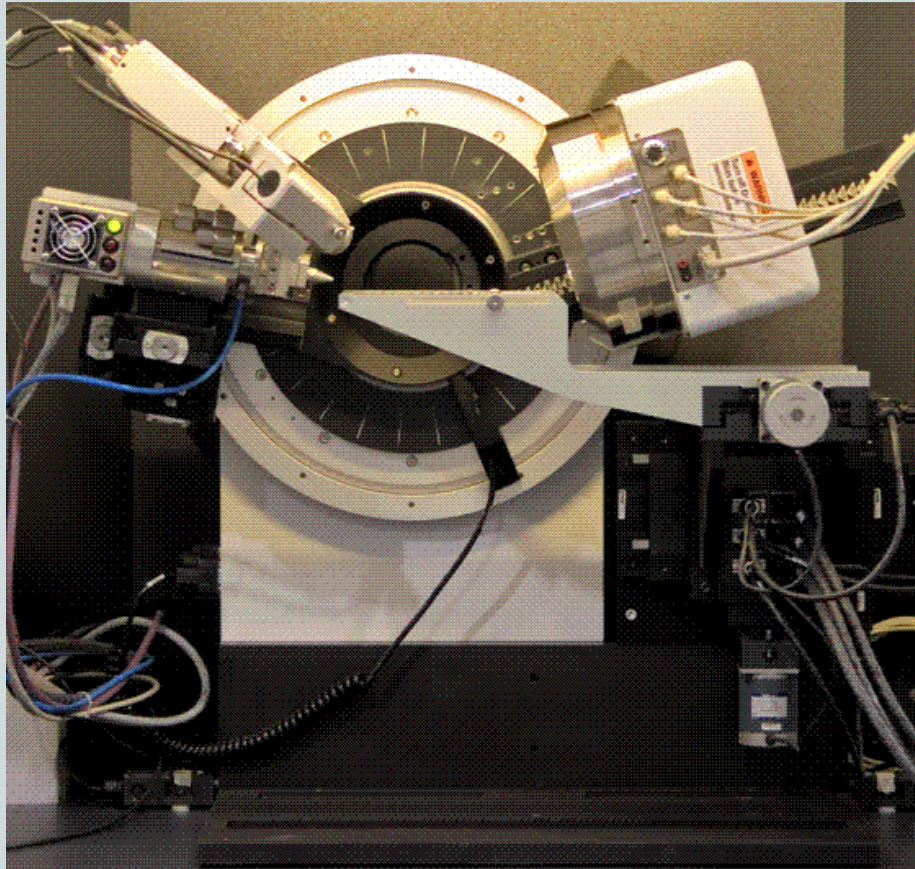
XRD²: Particle size measurement by γ profile analysis:



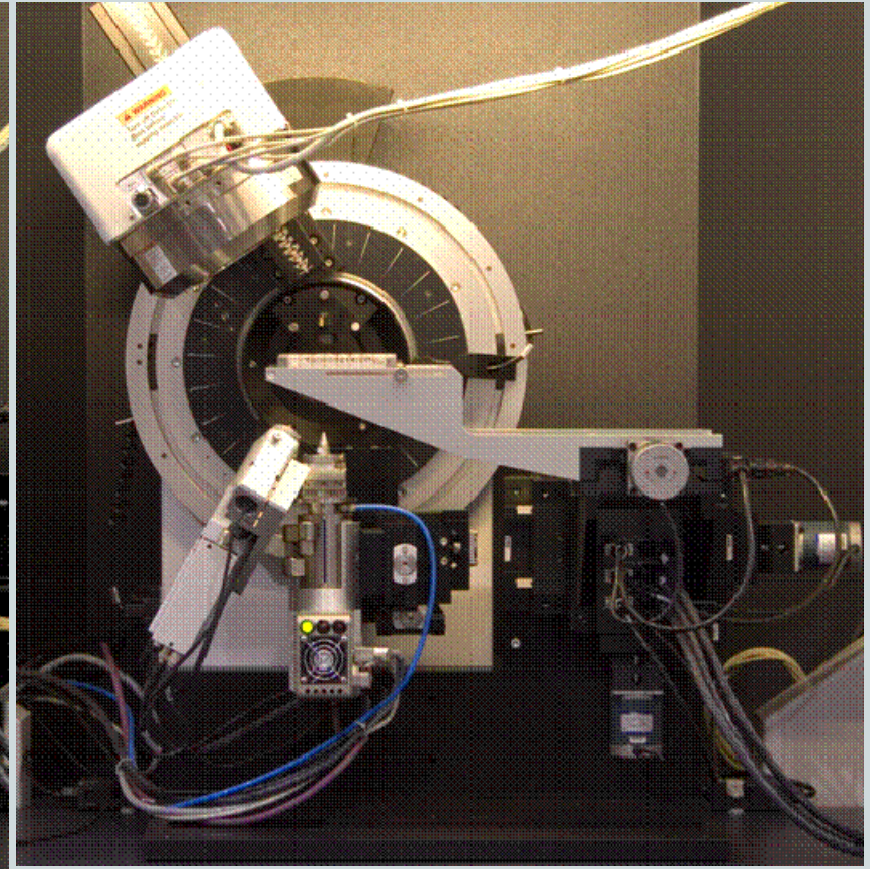
For XRD², the instrumental window Ω is given by

$$\Omega = \beta_1 \beta_2 = 2\beta \arcsin[\cos \theta \sin(\Delta\gamma / 2)]$$

D8 DISCOVER with GADDS HTS ($1\mu\text{S}$): Crystallite size by Reflection & Transmission



- Reflection mode: Effective diffraction volume is determined by the beam size and μ .



- Transmission mode: Effective diffraction volume is determined by the beam size and t ($\approx 1/\mu$).

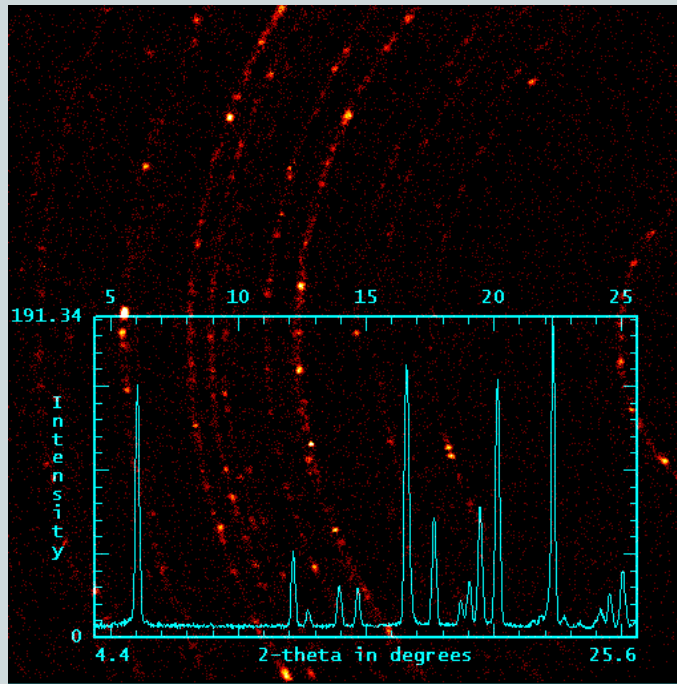
Comparison: Ibuprofen $I\mu$ S & VANTEC-2000 vs. Classical set-up



Sealed Tube

- 0.3 mm collimator
- Sample-Detector distance 29 cm

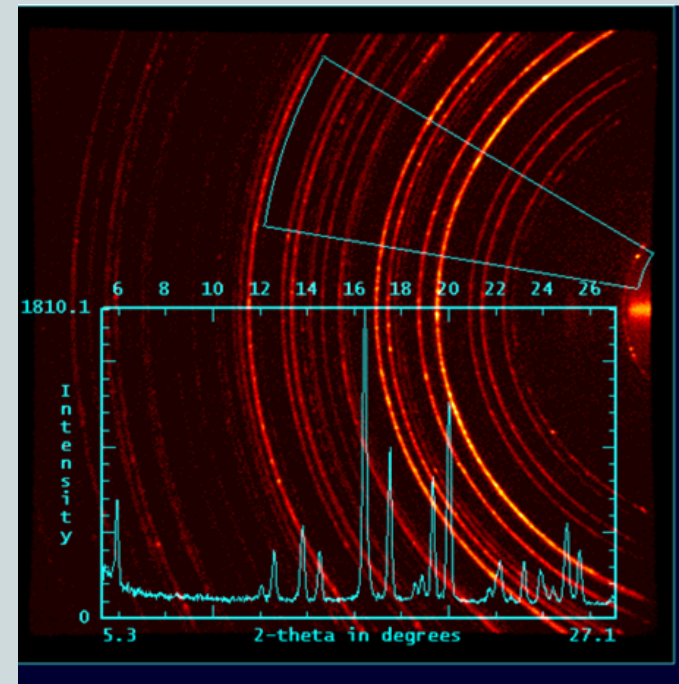
120 sec collection time



$I\mu$ S – XRD² – focus

- 2mmX2mm on sample, and 200um spot focused on detector
- small slice for integration to obtain better resolution

15 sec collection time



XRD²: Particle size measurement by γ profile analysis:

For XRD² in reflection mode, the effective sampling volume is given by

$$V = \frac{A_0 \cos \eta}{\mu(\cos \eta + \cos \zeta)} = \frac{\pi b^2 \cos \eta}{4\mu(\cos \eta + \cos \zeta)}$$

With $\cos \eta = \sin \omega \cos \psi$

and $\cos \zeta = -\cos 2\theta \sin \omega \cos \psi - \sin 2\theta \sin \gamma \cos \omega \cos \psi - \sin 2\theta \cos \gamma \sin \psi$

Where A_0 is the cross section of the incident x-ray beam and μ is the linear absorption coefficient.

For transmission mode with the incident beam perpendicular to the sample surface, we have the effective sampling volume

$$V = \frac{\pi b^2 \cos 2\theta \left[\exp(-\mu t) - \exp\left(-\frac{\mu t}{\cos 2\theta}\right) \right]}{4\mu(1 - \cos 2\theta)}$$

where t is the thickness of the sample.

XRD²: Particle size measurement by γ profile analysis:

For XRD² in reflection mode, the particle size is given by

$$d = k \left\{ \frac{p_{hkl} b^2 \arcsin[\cos \theta \sin(\Delta\gamma / 2)]}{\mu N_s} \right\}^{1/3}$$

where k is the instrumental calibration factor or can be calculated

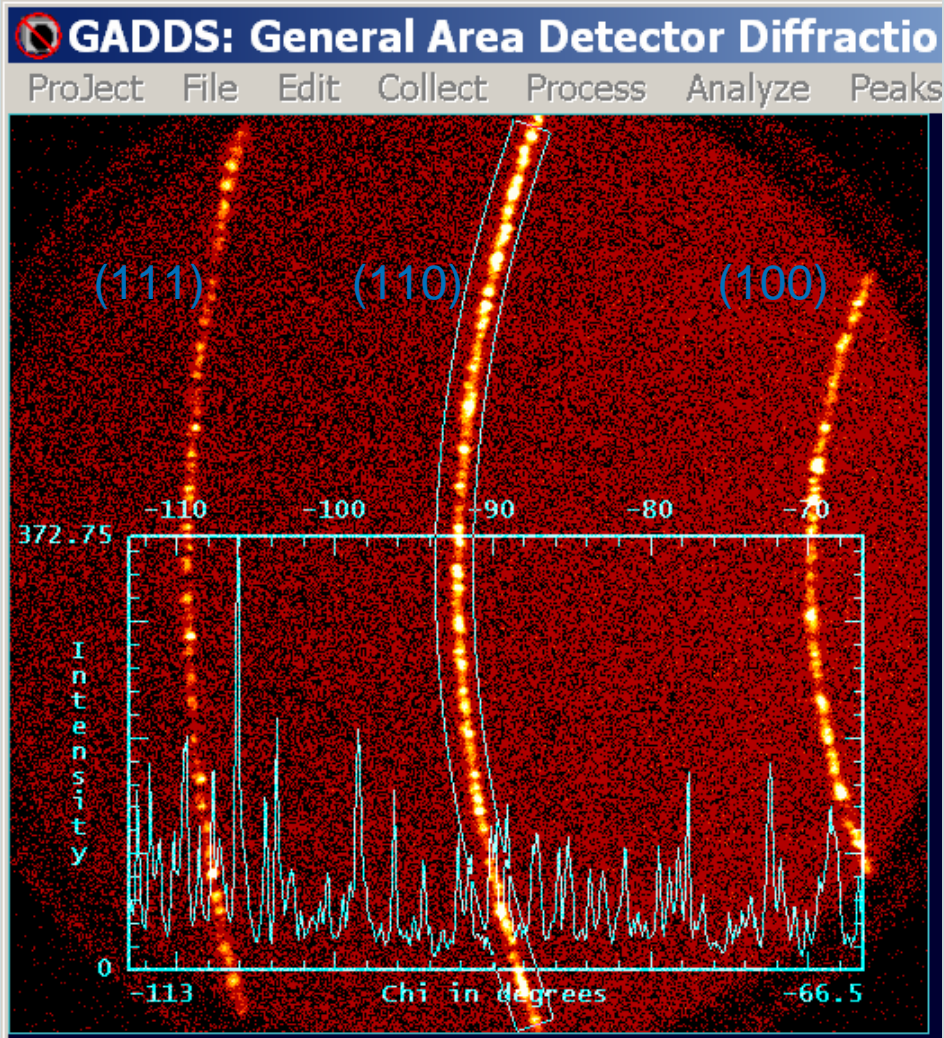
from $k = \left(\frac{3\beta}{8\pi} \right)^{1/3}$ if the instrument broadening in 2θ direction is known.

For transmission mode with the incident beam perpendicular to the sample surface, the particle size is given by

$$d = k \left\{ \frac{p_{hkl_i} b^2 t \arcsin[\cos \theta \sin(\Delta\gamma / 2)]}{N_s} \right\}^{1/3}$$

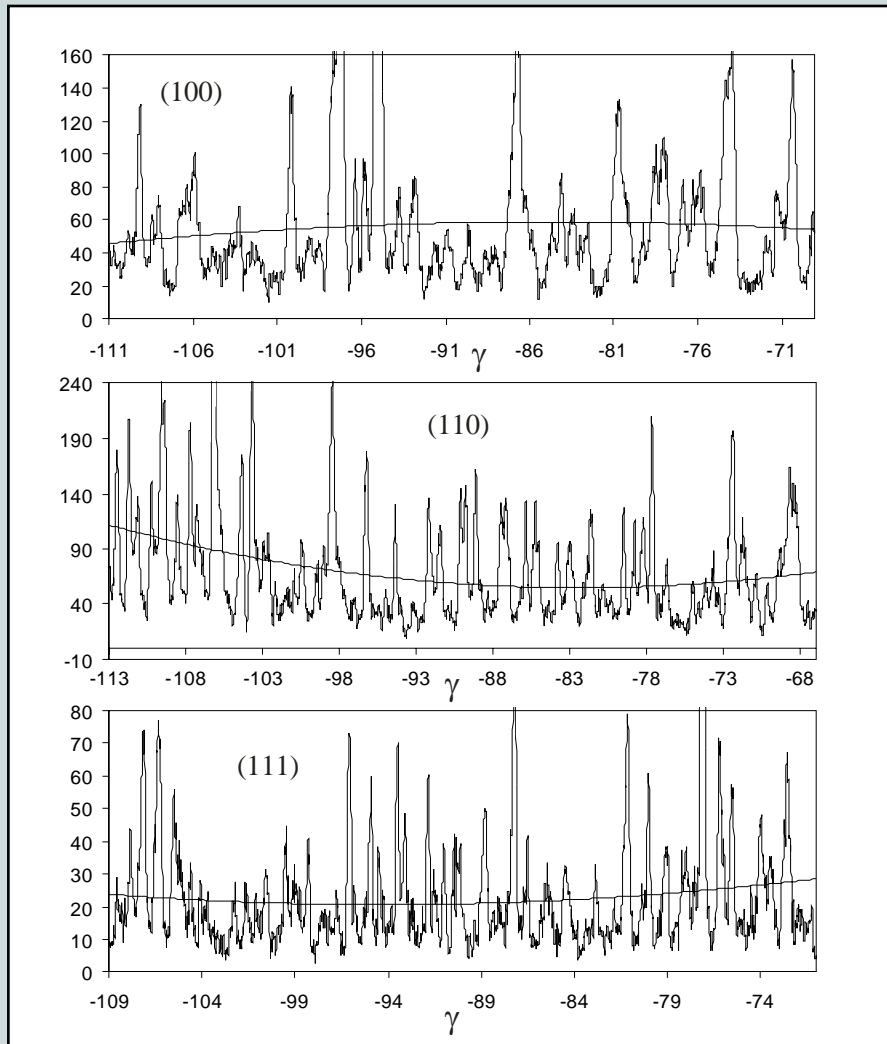
where k is the instrumental calibration factor or $k = \left(\frac{3\beta}{4\pi} \right)^{1/3}$

XRD²: Particle size measurement by γ profile analysis:



- The frame was collected from a SRM660a (LaB6) sample in transmission mode and Cu-K α x-rays.
- The 2D detector (Hi-Star™) is set at 23.75 cm from the instrument center.
- The beam (collimator pinhole) size b is 200 μm .
- The sample thickness t is 7.0 μm , based on the calculated μ of 1138 cm^{-1} and the measured transmission of 0.45.

XRD²: Particle size measurement by γ profile analysis:



- The 2θ -integrated plots (γ -profiles) of three rings from (100), (110) and (111) planes are displayed.
- The number of crystallites is counted from the number of intersections of the γ -profile with a threshold line.
- To cancel out the effects of the overall intensity fluctuation (texture, etc.), a 2nd order polynomial trend line is fitted to each γ -profile as a threshold line.
- Every two intersections of γ -profile with the threshold line represents a crystallite.

XRD²: Particle size measurement by γ profile analysis:

Calibration Results:

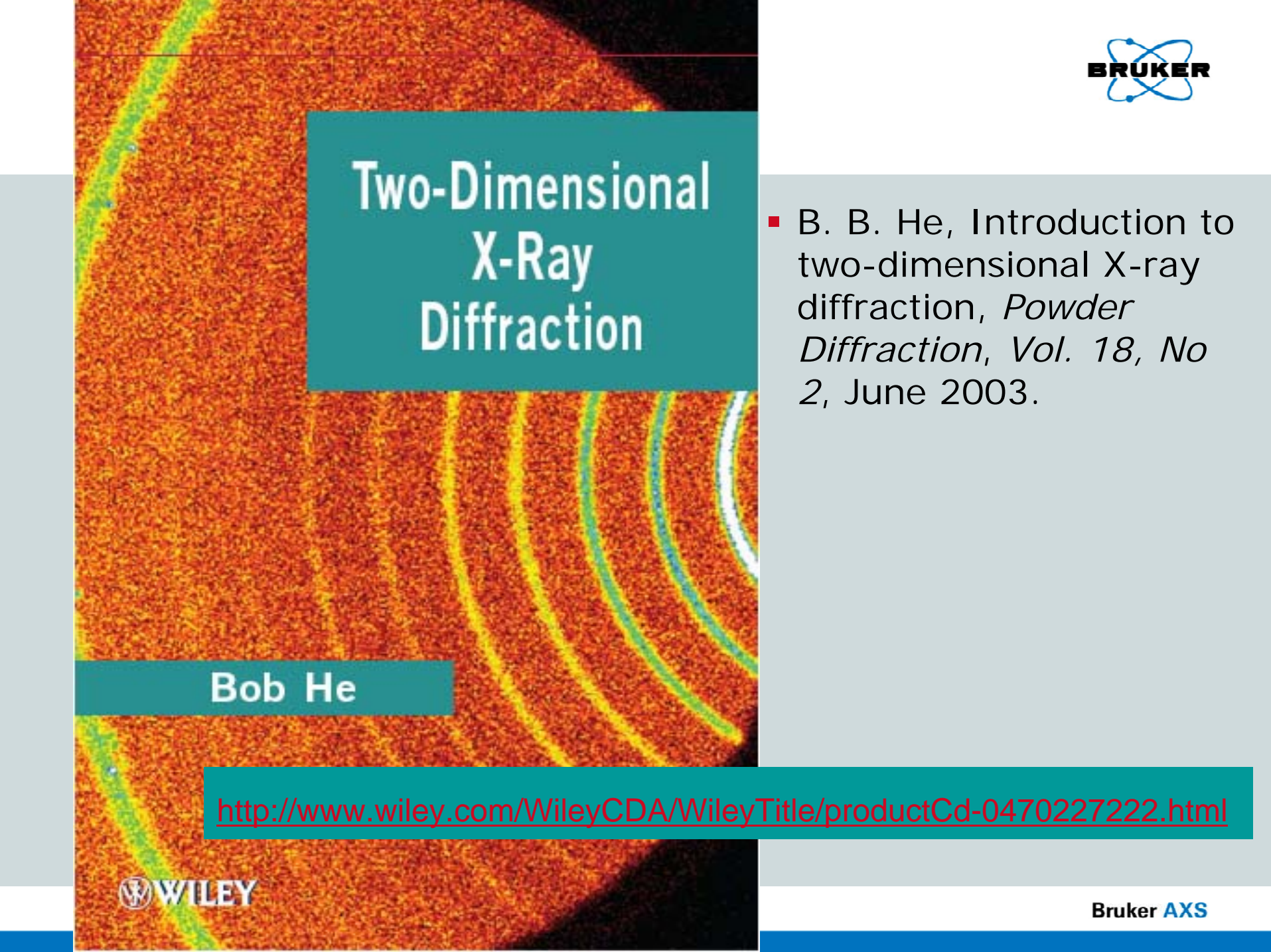
(hkl)	P_{hkl}	2θ	$\Delta\omega$	N_s	k
(100)	6	21.36	38	23	0.1217
(110)	12	30.38	46	41	0.1106
(111)	8	37.44	42	38	0.1281

- The average scaling factor k is 0.12 in this calibration. The system can then be used to measure the crystallite size of unknown materials if the data can be collected in approximately the same condition.
- It is always necessary to calibrate the system with a known standard, preferably with a comparable sample geometry and crystallite size.
- For reflection mode, it is critical to have a standard with a comparable linear absorption coefficient so as to have similar penetration.

XRD²: Particle size measurement by γ profile analysis:

The measurement range of crystallite size and γ resolution:

- The γ -resolution on crystal spots can be improved by using a long sample-to-detector distance.
- Reducing the x-ray beam size, beam divergence and sample thickness can reduce the number of spots along the γ -profile so as to reduce the demand for γ -resolution.
- Using a low multiplicity ring also reduces the demand for γ -resolution.
- In cases where too few diffraction spots can be observed (i.e. large grains) in the diffraction ring, a large beam size or sample oscillation (by rotation or translation) may improve the sampling statistics. However, the system should be calibrated in the same condition with a known sample having comparable crystallite size.
- Multi-target integration can deal with large grain size without new calibration. Only replace the calibrated k by k_n $k_n = n^{1/3}k$
 n is the number of the targets.
- The standard material may be diluted by light and amorphous materials. For example, a diluted LaB_6 sample with various linear absorption coefficients or matching thickness for profile analysis can be made by mixing with different amounts of starch.

The background of the slide is a two-dimensional X-ray diffraction pattern. It features a complex, colorful interference pattern with concentric rings and spots, primarily in shades of orange, red, and yellow, set against a dark background. The pattern is partially obscured by teal text boxes.

Two-Dimensional X-Ray Diffraction

Bob He

- B. B. He, Introduction to two-dimensional X-ray diffraction, *Powder Diffraction*, Vol. 18, No 2, June 2003.

<http://www.wiley.com/WileyCDA/WileyTitle/productCd-0470227222.html>